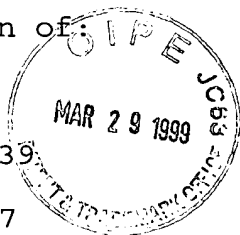


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: )  
)  
NISHIMOTO et al )  
)  
Serial No.: 08/897,839 )  
)  
Filed: July 21, 1997 )  
)  
For: STRESS-ADJUSTED INSULATING )  
FILM FORMING METHOD, )  
SEMICONDUCTOR DEVICE AND )  
METHOD OF MANUFACTURING THE )  
SAME )



Group Art Unit: 2814

Examiner: K. Eaton

*5/10/99*  
*24*  
*G. Stanley*  
*4-8-99*

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of October 29, 1998, initially set to expire January 29, 1999, be extended two months up to and including March 29, 1999. The requisite \$380.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to our Deposit Account No. 12-2174. A duplicate copy of this sheet is attached.

Respectfully submitted,

*George A. Loud*  
George A. Loud  
Reg. No. 25,814

Dated: March 29, 1999

LORUSSO & LOUD  
3137 Mt. Vernon Avenue  
Alexandria, VA 22305

(703) 739-9393

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